Oxford Instruments EDS AggieFab Texas A&M University

AggieFab Nanofabrication Facility





Department of Electrical & Computer Engineering 1. Start SEM and EDS

- 2. EDS components
  - > Project
  - > Nevigator
    - Scan image
    - Map
    - Spectral

3. Finish EDS





A M

### □ SCOPE

- The purpose of this document is to describe requirements and basic operating instructions for the FEI Helios SEM/FIB System. The use of this tool is limited to approved processes only.
  AFETY
- □ SAFETY
  - Be sure that you are trained and signed off to use this equipment.
  - Be sure to keep all doors and protective shields in place before operating this equipment.
  - Use care when operating around high voltage or high current.
  - If you are unsure about any procedure or indication while operating this equipment be sure to contact a staff member or trainer for assistance.



# **Starting EDS**

- 1. Start SEM and do the e-beam alignment at 15 kV or higher.
  - 1. Please refer to the SEM operational manual if needed
- 2. Turn on the EDS PC monitor
- 3. Start the EDS operating software: 'AZtecOne'



TEXAS A&M UNIVERSITY

Department of Electrical

& Computer Engineering

Texas A&M Engineering

Experiment Station

TEXAS A&M

ĀМ

### **Get EDS detector operational**

- 1. In the status bar, click the icon pointed by the red arrow
- 2. Thermal tap click 'Operate': wait until the status changes to 'Cold'
- 3. Insertion tap click 'In' position: you will see the detector moving in.



Texas A&M Engineering

**Experiment Station** 

Department of Electrical

& Computer Engineering

TEXAS A&M

ĀМ

### **Project**



Specimen: one or more sites of interest, for example, sample #. Up to 5 stubs can be loaded.

Site: interested area for data acquisitions

Note: Any project is representated by a folder which is saved with the name and location that you specify when you create and save a new project.



ĀМ

TEXAS A&M

Texas A&M Engineering

**Experiment Station** 

Department of Electrical

& Computer Engineering

### Specimen Details



#### AggieFab Nanofabrication Facility

#### $\prod_{U \ N \ I \ V \ E \ R} A \& M_{U \ N \ I \ V \ E \ R} A \& M_{Y}$





### Scan image



#### Annotating





TEXAS A&M

A M

Use the annotating tools if needed

# Мар





- 1. Select the map acquisition tool (left)
- 2. Outline the acquisition region using mouse drag



### Spectra





1. 'Thermal' tap – click 'Standby'
2. Insertion – click 'Out'
3. Close the 'AZtecOne'
4. Power off the monitor





ĀМ

TEXAS A&M UNIVERSITY

Department of Electrical

& Computer Engineering

#### SIGNATURES AND REVISION HISTORY

- 1. Original author of this document: Dr. Sung Oh Woo
- 2. Original author Title or Role: Research Engineer
- 3. Date of original: 8/1/2024
- 4. Revision B notes: description of the LMIS handling is added

#### Sandra Malhotra **Approvals:** Technical Manager Signature:

8/2/2024 Date:

| Revision       | Author      | Date     |
|----------------|-------------|----------|
| Original Issue | Sung Oh Woo | 8/1/2024 |
|                |             |          |
|                |             |          |
|                |             |          |
|                |             |          |
|                |             |          |
|                |             |          |
|                |             |          |



